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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Applicants: Y. TANABE, et al.

Serial No.: 10/774,589

Filed: February 10, 2004

Title: METHOD FOR FABRICATING SEMICONDUCTOR
INTEGRATED CURCUIT DEVICE

Allowed: February 9, 2005

Group: 2818

Examiner: David Vu

Confirmation No.: 1087

SUBMISSION OF DOCUMENTS UNDER 37 CFR 1.56**Mail Stop: ISSUE FEE**

Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

August 8, 2005

SIR:

Pursuant to Applicants' duty of disclosure, enclosed please find a copy of an Office Action in connection with a corresponding foreign (Chinese) patent application, as well as an English translation of a text portion of this Office Action, a copy of a document cited in this Office Action, and an English translation of this cited document. Also enclosed, for the convenience of the Examiner, is a Form PTO/SB/08A and B, listing the enclosed documents.

The enclosed documents are being submitted subsequent to payment of the Issue Fee in the above-identified application, and are being submitted in order to satisfy Applicants' duty of disclosure under 37 CFR 1.56.


Entry of the enclosed documents in the file of the above-identified application, and consideration of the enclosed documents to the extent necessary and proper, are respectfully requested.

Applicants request any shortage of fees due in connection with the filing of this paper be charged to the Deposit Account of Antonelli, Terry, Stout & Kraus, LLP,

Deposit Account No. 01-2135 (case No. 501.374654CC9), and credit any excess fees to such account.

Respectfully submitted,

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